



#8  
TZ 4/10/03 1734

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Examiner :  
Serial No. : 09/628,405  
Filed : August 1, 2000  
Inventor : Ichiro Tanokuchi  
          : Sachihiro Iida  
Title : GAS WIPING APPARATUS  
       : AND METHOD

Docket No.: 1299-00

035811

Confirmation No.: 5642

PATENT & TRADEMARK OFFICE

Dated: March 27, 2003

CHANGE OF ADDRESS

Commissioner for Patents  
Washington, DC 20231

Sir:

The address of the attorney of record for the above-identified application has changed to the following new address:



035811

PATENT TRADEMARK OFFICE

RECEIVED  
APR 09 2003  
GROUP 1700

We respectfully request that the address in the official file of this application be changed to the above new address, effective immediately, and that all future correspondence and communications be sent to that new address.

Respectfully submitted,

T. Daniel Christenbury  
Reg. No. 31,750

TDC:kr  
(215) 656-3300